



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: **Chung-Hui Chen**

Examiner: **Unknown**

Serial No.: **10/784,705**

Group Art Unit: **Unknown**

Filed: **February 23, 2004**

Attorney Docket No.: **N1280-00100**

For: **PROGRAMMABLE MOS DEVICE FORMED BY STRESSING  
POLYCRYSTALLINE SILICON**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

This Information Disclosure Statement is being filed in connection with the patent application referenced above. The Examiner is requested to consider each of the references cited herein and forward an initialed copy of the enclosed PTO Form 1449 to the undersigned representative. This Statement is being filed:

- ☐ Upon filing the application.
- ☒ Within three months from the filing date of this application, which is not a continued prosecution application.
- ☐ Within three months from date of entry of the national stage for this application.
- ☐ Before the mailing date of a first Office action on the merits for this application.
- ☐ Before the mailing date of a first Office action after the filing of a request for continued examination.
- ☐ Before the mailing date of any of: (i) a Final Office Action, (ii) a Notice of Allowance, and (iii) any other action that closes prosecution of this application. The Statement is accompanied by:
  - ☐ A Statement pursuant to 37 C.F.R. §1.97(e) or
  - ☐ The fee set forth in 37 C.F.R. §1.17(p), believed to be \_\_\_\_\_.
  - ☐ Before payment of the Issue Fee. The Statement is accompanied by:
  - ☐ A Statement pursuant to 37 C.F.R. §1.97(e) and
  - ☐ The fee set forth in 37 C.F.R. §1.17(p), believed to be \_\_\_\_\_.

## I. Provision of Copies

☒ A copy of each of the references listed on the attached Form PTO Form 1449 is enclosed herewith and forms a part hereof.

☐ A translation of References AA, AB and AC are enclosed herewith and form a part hereof.

☐ A copy of the European Search Report from a corresponding or related EPO application is enclosed herewith.

☐ A copy of the International Search Report from a corresponding or related PCT application is enclosed herewith.

☐ This application claims priority, pursuant to 35 U.S.C. §120, to prior U.S. Application No. \_\_\_\_\_, filed \_\_\_\_\_. References not submitted herewith were submitted to or cited by the Office in the prior application(s).

## II. Fee

☒ No fee is believed due in connection with filing of this Statement. However, in the event a fee or refund is due, the Commissioner is authorized to charge any fee associated with this communication or credit any overpayment to Deposit Account No. 04-1679 (N1280-00100).

☐ The fee in the amount \$ \_\_\_\_\_ that is due in connection of filing of this Statement was paid upon electronic filing of a corresponding Statement, which was made on \_\_\_\_\_ using the ePAVE software.

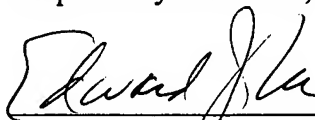
☐ The fee set forth in 37 C.F.R. §1.17(p), believed to be \$ \_\_\_\_\_, is believed to be due in connection of filing of this Statement.

☐ A check in the amount \$ \_\_\_\_\_ is enclosed.

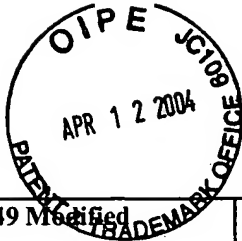
☒ The Commissioner is authorized to charge any other fee associated with this communication, or credit any overpayment, to Deposit Account No. 04-1679 (N1280-00100).

Respectfully submitted,

Dated: Apr 8, 2004

  
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Form PTO-1449 Modified  List of Patent and Publications Cited by Applicant (Use several sheets if necessary) U.S. Department of Commerce Patent and Trademark Office	Docket No. N1280-00100(TSMC2003-841)	Serial No. Unassigned
	Applicant Chung-Hui Chen et al.	
	Filing Date 02/23/2004	Group Unknown

## U. S. PATENT DOCUMENTS

Examiner Initial	Cite No.	Document No.	Kind Code (if known)	Name	Date	Class	Subclass
	1.	6,507,087 B1		Yu	01/14/2003	257/529	
	2.	6,445,606 B1		Khoury	09/03/2002	365/96	
	3.	6,436,738 B1		Yu	08/20/2002	438/132	
	4.	6,208,549 B1		Rao et al.	03/27/2001	365/96	

## FOREIGN PATENT DOCUMENTS

Examiner Initial	Cite No.	Country Number Code	Kind Code	Publication Date	Name of Patentee or Applicant	Page, Columns, Lines where Relevant Passages Appeal	T

## OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initial	Cite No.	(Include name of author in CAPITAL LETTERS, Title of the Article (when appropriate) title of the item (book, magazine, journal, symposium, catalog, etc.) date, pages, volume, issue number(s), publisher, city and/or country where published)	T
	5.	Ker, Ming-Dou et al., "CAPACITOR-COUPLE ESD PROTECTION CIRCUIT FOR DEEP-SUBMICRON LOW-VOLTAGE CMOS ASIC", IEEE Transactions on Very Large Scale Integration (VLSI) Systems, Vol. 4, No. 3, (SEPT. 1996), pp. 307-321	
	6.	Ker, Ming-Dou et al., "COMPLEMENTARY-SCR ESD PROTECTION CIRCUIT WITH INTERDIGITATED FINGER-TYPE LAYOUT FOR INPUT PADS OF SUBMICRON CMOS IC'S", IEEE Transactions on Electron Devices, Vol. 42, No. 7, (JUL 1995), pp. 1297-1304	
	7.	Wu et al., A NEW ON-CHIP ESD PROTECTION CIRCUIT WITH DUAL PARASITIC SCR STRUCTURES FOR CMOS VLSI, IEEE Journal of Solid-State Circuits, Vol. 27, No. 3, (MAR 1992), pp. 274-280	

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.